

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Serial No.: 10/808,691  
Applicant: Kostenko et al.  
Art Unit: 1746  
Title: **METHOD AND PROCESSING SYSTEM FOR PLASMA  
ENHANCED CLEANING OF SYSTEM COMPONENTS**  
Attorney Docket: FKL-017  
Confirmation No.: 6065

Cincinnati, Ohio 45202

March 21, 2007

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT AND RESPONSE TO ELECTION/RESTRICTION REQUIREMENT**

This paper is responsive to the Office Action dated March 13, 2007. The present response includes the following:

Amendments to the Specification:	None
Amendments to the Claims:	Pages 2-8
Amendments to the Abstract:	None
Amendments to the Drawings:	None
Remarks:	Pages 9-10
Attachments:	None